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SERIAL NUMBER
09/984,648
RECOGNIZED
09/28/2001
RULE

CONFIRMATION NO. 1952

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|--|--|------------------------------|---|-------------------------------------|
| SERIAL NUMBER 09/984,648 | FILING DATE 09/28/2001 RULE | CLASS 438 | GROUP ART UNIT 2812 | ATTORNEY DOCKET NO. 882.C2397 |
| APPLICANTS Koji Yashimura, Tochigi, JAPAN; CONTINUING DATA <i>YONG</i> FOREIGN APPLICATIONS JAPAN 2000/302162 10/02/2000 JAPAN 2001/089762 03/27/2001 | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED 11/14/2001 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No US USC 119 (a-d) conditions <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input type="checkbox"/> Not other not Allowance Initials | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 15 | TOTAL CLAIMS 27 45 |
| ADDRESS 05514 | | | | |
| TITLE Exposure apparatus, semiconductor device manufacturing method, exposure apparatus maintenance method and semiconductor manufacturing factory | | | | |
| FILING FEE RECEIVED 1398 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |

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